

Notice of References Cited	Application/Control No. 10/720,579		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner EDNA WONG		Art Unit 1795	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,834,140	11-1998	Wolski et al.	429/220
*	B	US-5,863,410	01-1999	Yates et al.	205/585
*	C	US-5,863,666	01-1999	Merchant et al.	428/544
*	D	US-6,562,222	05-2003	Sekiguchi et al.	205/296
*	E	US-5,215,646	06-1993	Wolski et al.	205/77
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	WO 0153569 A1	07-2001	World Intellect	SEKIGUCHI J et al.	C25D 3/38
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)			
	U	Whalen, "Polymer Technology Dictionary", © no month, 1994, p. 256.			
	V	Parsons et al., "Effect of Gelatin on the Changes in Initial Cathode Polarization During Electrodeposition of Copper", Canadian J. of Chem. (no month, 1954), Vol. 32, pp. 581-590.			
	W				
	X				

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.